

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of)
Yamazaki et al.)
Serial No.:)
Filed:)
For: Semiconductor Device And)
Manufacturing Method Thereof)
Art Unit:)
Examiner:)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents , P.O. Box 1450, Alexandria, VA 22313-1450 on	
<u>August 18, 2003</u> (Date of Deposit)	
<u>Shannon Wallace</u> Name of applicant, assignee, or Registered Rep.	
<u>Shannon Wallace</u> Signature	<u>8/18/03</u> Date

Commissioner for Patents
P.O. Box 1450

August 18, 2003

PRELIMINARY AMENDMENT A

Sir:

Prior to examination, please amend the above-identified application as follows:

IN THE DRAWINGS:

The attached sheet contains a change to Fig. 6C. This sheet, which includes Figs. 6A-6D, replaces the original sheet including Figs. 6A-6D. Replacement formal drawings for all the figures are also being submitted.